



General Chair: Pär Omling

- 7 topical areas: Nano & ICNT+T, Thin films, Surface Science, Semiconductor materials and Devices, Vacuum technology, Materials and Life sciences, Large scale facilities

- Industrial/Sponsor Exhibition
- Short Courses
- Visit to the synchrotron MAX4 and the European Spallation Source (ESS).

Balanced financial statement with an almost zero net result.

This includes the planned payment of 40.000 SF to IUVSTA and a small negative result on the "Short Courses".



Around 800 persons from 41 countries and 30 companies/sponsors

Geographic distribution among the participants: Europe 64 %, Asia 23 %, North America 4 %

20% of students

668 scientific presentations: 8 Plenary talks 85 Invited talks 268 Oral talks 307 Posters

Remark: Unfortunate Conference dates

-from a national perspective since the biggest Swedish political/industrial/lobbying event was the same week making it very difficult to attract Swedish Exhibitors.

-from a US perspective since it is the week when the National Day in US is celebrated.







Prizes and awards

IUVSTA Prize for Science: Professor Emeritus David Phillip Woodruff, Department of Physics, University of Warwick, United Kingdom

Prize Lecture "Determining surface structure: why and how?"

IUVSTA Prize for Technology: Research (Emeritus) Professor Reshef Tenne, Department of Materials and Interfaces, Faculty of Chemistry, Weizmann Institute of Science, Rehovot, Israel

Prize lecture on "2D materials: Inorganic nanotubes and fullerene-like nanoparticles at the crossroad between materials science and nanotechnology and their applications"

IUVSTA Elsevier Student Travel Award given to 10 students

ICSS-17, ICN+T 2019, NanoForum 2019 July 1st-5th, 2019 • Malmö • Sweden

IUVSTA EBARA Award

VC-21

to support innovation in environmentally friendly solutions in the area of vacuum-related science and technologies

Waqas Hassan Tanveer Research Associate at Heriot Watt University, Edinburgh, UK.

Award ceremony and prize lecture during a special IUVSTA Anniversary session

Prize lecture: The key role vacuum-based technologies are playing to improve efficiencies of novel technologies for environmental benefits





June 14-18, 2020 • Budapest, Hungary



Venue: ELTE University Congress Center

FullEUR 590PhD studentEUR 350Accompanying EUR 300

Including:

coffee breaks and lunches

admission to the Welcome Reception and to the Conference Dinner and to social programs

Number of registered colleagues	207
Plenary speakers Invited speakers	4 16
Submitted abstracts	171
-Accepted for oral presentation	80
-Accepted for poster presentation	71

Selected papers will be published in a special issue of Vacuum (IF: 2.5)





June 14-18, 2020 • Budapest, Hungary



ORGANIZERS

- Hungarian Vacuum Society (HVS)
- Division of Vacuum Physics, Technology and Applications of Lóránd Eötvös Physical Society
- ICTF-18 is endorsed and co-organized by the Thin Film Division of IUVSTA
- Organizer partner: AKCongress

Conference chair



Prof. József Gyulai

Conference co-chair



Dr. Béla Pécz

June 14–18, 2020 • Budapest, Hungary

200

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SCIENTIFIC PROGRAM SCHEDULE

Sunday	Monday	Tuesday	Wednesday	Thursday
	9:00-13:00	9:00-13:00	9:00-13:00	9:00-13:00
	Opening, Lectures & Coffee Breaks	Lectures & Coffee Breaks	Lectures & Coffee Breaks	Lectures & Coffee Breaks & Closing
	13:00-15:00	13:00-15:00	13:00-15:00	13:00-15:00
	Lunch	Lunch	Lunch	Lunch
17:00 – Registration	15:00-18:00 Oral & Poster	15:00 Social program	15:00-18:00 Oral & Poster	
& Welcome Sessions & Reception Coffee Breaks	19:00 Conference dinner	Sessions & Coffee Breaks		

June 14-18, 2020 • Budapest, Hungary



PLENARY SPEAKERS



Aeschlimann, Martin: *Plasmonics at the space-time limit*

Hendricks, Jay H.: *NIST on a Chip: Photonic quantum-based measurements for vacuum and beyond*



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PLENARY SPEAKERS



Hultman, Lars: Self-organized nanostructure design in functional nitride alloy films

Wágner, Tomáš: Deposition of amorphous thin films



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Торіс		Oral (including PL & IN)	Poster	Total in the Topic
Applied Surface Science	(ASS)	12	7	19
Biointerfaces	(Bio)	1	2	3
Plasma Science & Technique	(PST)	6	3	9
Surface Engineering	(SE)	6	8	14
Surface Science	(SS)	10	6	16
Thin film growth mechanism and models, new approaches	(TFgrow)	17	5	22
Thin film multilayer and superlattices	(TFmulti)	6	2	8
Semiconductor, dielectric, ferroelectric & piezoelectric thin films	(Semi)	7	4	11
Magnetic, superconducting and multiferroic thin films	(Magnet)	2	1	3
Thin films for optoelectronics, nanoelectronics, spintronics and batteries	(TFopto)	5	13	18
Thin film solar cells: inorganic, organic, perovskites etc.	(TFsolar)	1	3	4
Thin film sensors & actuators	(TFsensor)	9	4	13
Vacuum Science & Technique	(VST)	7	4	11
Electronic Materials and Processing	(EMP)	3	0	3
Nanometer Structures	(NS)	8	9	17
Total submitted		100	71	171

June 14-18, 2020 • Budapest, Hungary





https://www.ictf-jvc.com/



Deadline of abstract submission and early bird payment postponed to 15 April, 2020.

ICN+T July 19-24 2020 Vancouver

http://icnt2020.org/

- Speaker list •
- Abstracts still open
- Sponsors and exhibitors open •
- Conference timetable overview
- Confirmed speaker list (20 speakers)
- Venue: Hyatt Regency Vancouver
 - Accomodation code available 0
- Registration no yet available
 - Working with venue to postpor 0 meeting



"The only update we can really give at the moment is "stay tuned""

Sarah Burke and Sander Otte, co-chairs



Conference Chair: Professor Ludger WIRTZ,

Department of Physics and Materials Science, University of Luxembourg





Prof. Eva Y. ANDREI







Aarhus University, DK



Prof. Karina MORGENSTERN

Ruhr-University Bochum, DE



Prof. Alec M. WODTKE

12 confirmed invited speakers. Parity almost respected !

Prof. Ulrich HÖFER

Universität Marburg, DE

CONFIRMED PLENARY SPEAKERS



	Sunday 23/08	Monday 24/08	Tuesday 25/08	Wednesday 26/08	Thursday 27/08	Friday 28/08
8:30 AM						
9:00 AM		ECOSS registration	Plenary 2	Plenary 3	Plenary 4	Plenary 5
10:00 AM		Plenary 1	Colontifio program	Scientific program	Colontific program	Colontific program
11:00 AM		Scientific program	Scientific program	Scientific program	Scientific program	Scientific program
12:00 PM		Lunch	Lunch	Lunch	Lunch	Lunch
2:00 PM				Scientific program		
4:00 PM	Walaana Daaantian	Scientific program /elcome Reception	Scientific program	Bus shuttles	Scientific program	Scientific program
6:00 PM	welcome Reception			Colo Dianas Cavias		
7:00 PM				Gala Dinner Cruise		
11:00 PM				Bus shuttles		



Call for abstracts for talks/posters: February 16, 2020

Registration is opened!

Deadlines for:

Abstract submission:	March 31, 2020
Notification of abstract acceptance:	May 10, 2020
Application for grants/prizes:	June 1, 2020
Early bird registration:	June 7, 2020
Regular registration:	July 31, 2020



FULL CONGRESS REGISTRATION	EARLY REGISTRATION	REGULAR REGISTRATION	LATE REGISTRATION
	Available until June 7, 2020	Between June 8-August 22, 2020	After August 22, 2020
Regular delegate member of EPS*	380 EUR	430 EUR	480 EUR
Regular delegate	430 EUR	480 EUR	530 EUR
PhD student member of EPS*	180 EUR	230 EUR	280 EUR
PhD student*	230 EUR	280 EUR	330 EUR

PARTIAL CONGRESS REGISTRATION	EARLY REGISTRATION	REGULAR REGISTRATION	LATE REGISTRATION
	Available until June 7, 2020	Between June 8-August 22, 2020	After August 22, 2020
Accompanying person	50 EUR	50 EUR	50 EUR
Single day	200 EUR	200 EUR	200 EUR



Prizes and Awards

ECOSS Prize

PhD within 2 years before the beginning of the conference 1 500 € for the best oral presentation

EPS Poster Prize

PhD student 200 € for the best poster presentation

EPS Travel Prize

Young researchers (PhD within 6 years) working at a European Institution 350 € travel grant and waived registration fees for the three awardees





VASSCAA-10 & CVS 2020

10th Vacuum and Surface Science Conference of Asia and Australia & Chinese Vacuum Society Congress 2020

October 11-14, 2020 | Shanghai, China

http://vasscaa2020.csp.escience.cn

Divisions and Parallel Sessions

- 1. Vacuum Science & Technology (VS)
- 2. Surface Science (SS) / Applied Surface Science (AS)
- 3. Nanosciences (NS)
- 4. Thin Film (TF)/Surface Engineering (SE)
- Electronic Materials & Processing (EM) / Display Technology (DT)
- 6. Plasma and Plasmonics (PP)
- 7. Biointerfaces and Multidisciplinary (BM)
- 8. CVS special activity (in Chinese)



Guanghua Building, Fudan University Shanghai, China

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Organizers

Chinese Vacuum Society



Institute of Physics, CAS



Fudan University

- Plenary lectures Monday morning and Wednesday afternoon.
- From Monday afternoon to Wednesday morning, parallel sessions.
- 3-days exhibition
- IUVSTA-Elsevier student Award

Important days

Jul 2020	Deadline for
31	Submission of Abstract
Jul 2020	Deadline for
31	Early Bird
Aug 2020	Notification of
31	Acceptance
Sep 2020	Deadline for
15	Registration
Sep 2020	Deadline for
15	Hotel Reservation

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October 11-14, 2020 | Shanghai, China







Oct. 9-11 Suzhou





The World Hotel Grand DuShu Lake Suzhou

- Suzhou is about 80 km to the west of Shanghai
- In the afternoon of Oct. 11, bus is provided from Suzhou to Shanghai



30 May - 4 June 2021, Marseille, France www.evc16.org

Web site under construction

TOPICS

- ASS Applied Surface Science
- BIO Biointerfaces
- EMP Electronic Materials & Processing
- NSN Nanometer Structures & Nanotechnology
- PST Plasma Science & Technique
- SE Surface Engineering
- SS Surface Science
- TF Thin Film
- VST Vacuum Science and Technology

Special ITER topic: energy, plasma and materials







WITH THE SUPPORT OF





Irina Martin-Graur IUSTI, Aix Marseille Univ.



Co-chair

Jean-Louis Bersier ITER Organization



30 May - 4 June 2021, Marseille, France www.evc16.org

Web site under construction









CONFERENCE SECRETARY: FRENCH VACUUM SOCIETY

Société Française du Vide (SFV) 19 rue du Renard F-75004 Paris +33 (0)1 53 01 90 30- sfv@vide.org- www.vide.org



International Vacuum Congress (IVC-22, ICSS, ICN+T, VASSCAA)

Co-organized with International symposium on sputtering plasm processes International colloquium on scanning probe microscopy

Sapporo – Japan September 11(Sun) – 16 (Fri), 2022

> Chair: President of JVSS Ex. Councilor: Katsuyuki Fukutani (Tokyo,



Venue: Sapporo Convention Center

https://ivc22.org

Program committee

Chair: Hidemi Shigekawa (Tsukuba) Vice-chair: Yukio Hasegawa (Tokyo)

> ✓ We will ask the chairs and the Japanese representatives of IUVSTA nine divisions to be committee members.

Cf. F. Komori (SSD vice-chair), S. Hamaguchi (PSTD chair)

S. Hasegawa (NSD vice-chair) from Japan

Exhibition committee

Chair: M. Tsujimura (Ebara) & H. Obinata (ULVAC)
Vice-chair: M. Kuroiwa (Tokyo El.)
H. Yoshida, Y. Sato, S. Sekiguchi, T. Tazawa
K. Ohori, Y. Okano, M. Nakamura

Local arrangement

Kiyotaka Asakura (Sapporo) T. Shimada, T. Takakusaki, T. Abukawa, T. Kurabayashi

First Announcement of IVC-23 Sydney, 2025



- Please see our blog at www.ivc23.org
- PCO Selection
 - Tender submit 1st week April
 - Selection end of June
- Diversity (preliminary) statement drawn-up

First announcement of IVC-23

- February 16, 2020



IVC-23The 23rd International Vacuum Congress September 15-19, 2025, Sydney, AUSTRALIA Supporters Yes, for the first time in Australia/Please mark your calendars and get your funding prepared. This site will be updated regularly. Please check back. Enquiries to: admin@vacuumau.org

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